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Patent  
255/236  
P00-0021 B/D  
12/10/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ) Group Art Unit: 1746  
BERGMAN, Eric J. )  
Serial No.: 09/621,028 ) Examiner: F. Stinson  
Filed: July 21, 2000 )  
For: PROCESS AND APPARATUS FOR )  
TREATING A WORKPIECE SUCH AS A )  
SEMICONDUCTOR WAFER )

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NOV 29 2001  
TC 1700

SUPPLEMENTAL STATEMENT OF RELATED APPLICATIONS

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Further to Applicant's Preliminary Amendment mailed February 9, 2001, Applicant advises:

- 1) Serial No. 08/853,649 issued on June 5, 2001 as U.S. Patent No. 6,240,933.  
Continuations of 08/853,649 now pending are 09/811,925; 09/836,080 and 09/836,059.

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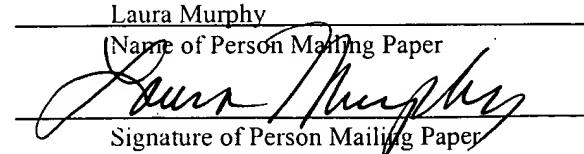
CERTIFICATE OF MAILING  
(37 C.F.R. §1.8a)

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LA-217139.1

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Laura Murphy  
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Signature of Person Mailing Paper

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P00-0021

2) Serial No. 09/061,318 is abandoned. Continuation/Divisional Applications of 09/061,318 are:

<u>Serial No.</u>	<u>Filing Date</u>	<u>Patent No.</u>
09/536,251	3/17/00	pending
09/677,934	10/2/00	6,267,125
09/677,929	10/2/00	6,273,108
09/677,925	10/2/00	pending
09/837,722	4/18/01	pending.

Copies of the patents listed above are attached to the accompanying Information Disclosure Statement. Copies of the pending claims from the applications listed above are enclosed.

Respectfully submitted,

LYON & LYON LLP

Dated: November 13, 2001

By: Kenneth H. Ohriner  
Kenneth H. Ohriner  
Reg. No. 31,646

633 West Fifth Street  
Suite 4700  
Los Angeles, California 90071-2066  
(213) 489-1600 - Fax (213) 955-0440  
Enclosures



Patent  
255/236  
P00-0021

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

**BERGMAN, Eric J.**

Serial No.: 09/621,028

Filed: July 21, 2000

For: **Process And Apparatus For Treating A  
Workpiece Such As A Semiconductor Wafer**

) Group Art Unit: 1746  
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Examiner: F. Stinson  
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*TC 1700*

**THIRD SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In compliance with the Applicants' duty under 37 CFR 1.97-98, the following information is brought to the attention of the Examiner. The items are listed on the attached form PTO-1449 and copies are enclosed for the convenience of the Examiner.

The item identified in this Supplemental Information Disclosure Statement may or may not be "material" pursuant to 37 CFR 1.56 and the submission thereof by Applicants shall not be construed as an admission that any such patent, publication or other information referred to therein is

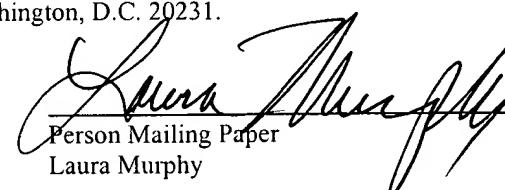
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(37 C.F.R. § 1.8a)

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Laura Murphy

Patent  
255/236  
P00-0021

material or considered to be material (37 CFR 1.97(h)), or even qualifies as "prior art" under 35 U.S.C. § 102 with respect to this invention unless specifically designated by Applicants as such.

The filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information, as defined in 37 CFR 1.56, exists.

Applicant believes that no fee should be required for consideration of this Information Disclosure Statement. Should Applicant be in error, however, please charge any fee required for the consideration of this paper to Deposit Account No. 12-2475.

Respectfully submitted,

LYON & LYON LLP

Dated: November 13, 2001

By: Kenneth H. Ohriner  
Kenneth H. Ohriner  
Reg. No. 31,646

633 West Fifth Street  
Suite 4700  
Los Angeles, California 90071-2066  
(213) 489-1600 – Fax (213) 955-0440